

| | | | |
|-----------------------------------|---------------------------------------|----------------------------------------------------------------|-------------|
| Notice of References Cited | Application/Control No. 10/066,169 | Applicant(s)/Patent Under Reexamination BONDESTAM ET AL. | |
| | Examiner Arlen Soderquist | Art Unit 1743 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--------------------------------------------------|-----------------|-----------------|----------------|
| | A | US-4,479,845 | 10-1984 | Nisizawa et al. | 117/86 |
| | B | US- | | | |
| | C | US- | | | |
| | D | US- | | | |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--------------------------------------------------|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|-------------------------------------------------------------------------------------------------|
| | U | Reath, M. et al, Proceedings - Institute of Environmental Sciences 1993, 39TH(VOL. 1), 119-123. |
| | V | Tedder, L. L. et al, Journal of Vacuum Science & Technology, A 1996, 14, 267-270. |
| | W | Gevelber, M. et al, Proceedings - Electrochemical Society 1996, 96-5, 157-162. |
| | X | Weerts, W. L. M. et al, Surface Science 1996, 367, 321-339. |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.